AMENDMENTS TO THE SPECIFICATION

Please rewrite the paragraph at page 1, lines 4-8 as follows:

-- BACKGROUND OF THE INVENTION

The invention relates to a fluidic microsystem with the characteristics according to the preamble of claim 1 and to a method for particle manipulation according to the preamble of claim 11, in particular for particle manipulation with high-frequency electrical fields. --.

Please delete the paragraph at page 3, lines 25-28 in its entirety.

Please add on page 3, line 29, the following heading:

-- SUMMARY OF THE INVENTION --

Please add on page 8, line 18, the following heading:

-- BRIEF DESCRIPTION OF SEVERAL VIEWS OF THE DRAWINGS --

Please add on page 9, line 13, the following heading:

-- DETAILED DESCRIPTION OF PREFERRED EMBODIMENTS --